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# CONTENTS

## Proceedings of ASME 2022 International Design Engineering Technical Conferences and Computers and Information in Engineering Conference Volume 8

### 16TH INTERNATIONAL CONFERENCE ON MICRO- AND NANOSYSTEMS (MNS)

#### Micro/Nano Bioengineering

- DETC2022-90378** ..... **V008T08A001**  
Development of a Novel Three-Dimensional Parallel-Plate Biochemical Sensor for Electrochemical Impedance Spectroscopy (EIS)  
*Negar Rafiee, Brian Huffman, and Mohammad Shavezipur*
- DETC2022-90637** ..... **V008T08A002**  
Relationships Among Band Tension, Sensor Pressure, Patient Comfort, and Pulsatile Signal Quality for Wrist Worn Health Monitoring Devices  
*Thomas Naylor, Roger Black, Cameron Hernandez, and Brian D. Jensen*
- DETC2022-91044** ..... **V008T08A003**  
Frequency Response of Parametric Resonance of Electrostatically Actuated Bio-MEMS Circular Membranes  
*Marcos Alipi and Dumitru I. Caruntu*

#### Micro/Nano Dynamics

- DETC2022-89600** ..... **V008T08A004**  
Anisotropic Approach to Control Viscous Fingering Pattern Generated in Lifting Plate Hele-Shaw Cell  
*Kiran S. Bhole, Bharatbhushan S. Kale, Sachin Mastud, Nilesh Raykar, Chetna Sharma, and Prashant Deshmukh*
- DETC2022-89669** ..... **V008T08A005**  
Bistability Condition for Electrostatically Actuated Initially Curved Micro-Beams in the Presence of Curved Electrodes  
*Lior Medina*
- DETC2022-89969** ..... **V008T08A006**  
Experimental Analysis of Flexural-Torsional Forced Vibrations of A Piezoelectric Double-Cantilever  
*Anahita Zargarani, John O'Donnell, and S. Nima Mahmoodi*
- DETC2022-90565** ..... **V008T08A007**  
Hysteresis Suppression in Coupled Resonators Under Simultaneous Primary and Superharmonic Excitations  
*Ming Lyu, Jian Zhao, Najib Kacem, Jiahao Song, Rongjian Sun, and Pengbo Liu*
- DETC2022-90568** ..... **V008T08A008**  
A Novel Mass Sensor Based on Parametrically Excited Mode-Localized Resonators  
*Jiahao Song, Jian Zhao, Najib Kacem, Ming Lyu, Rongjian Sun, and Pengbo Liu*

#### Micro/Nano IoT, Sensors, and Digital Computing

- DETC2022-90015** ..... **V008T08A009**  
Novel MEMS Capacitive Sensor Excited at Electrical Resonance for Detecting Helium Based on Changes in Air Electrical Properties  
*Sulaiman Mohaidat and Fadi Alsaleem*

**DETC2022-90093** ..... **V008T08A010**  
Design and Simulation of a MEMS Capacitive Pressure Sensor With Corrugated Membrane and Linear Capacitance-Pressure Response  
*Mohammad Shavezipur*

**DETC2022-90498** ..... **V008T08A011**  
A Three Degree of Freedom Model Approach to Enable a MEMS-Based Neural Computing Unit  
*Mohammad Megdadi, Hamed Nikfarjam, Mohammad Okour, Siavash Pourkamali, and Fadi Alsaleem*

**DETC2022-91236** ..... **V008T08A012**  
A Small MEMS Neural Network to Classify Human Sitting and Standing Activities  
*Mohammad Okour, Mohammad Megdadi, Hamed Nikfarjam, Siavash Pourkamali, and Fadi Alsaleem*

### **Micro/Nano Power Sources and Storage**

**DETC2022-89291** ..... **V008T08A013**  
Nuclear Batteries Enable Decades of Uninterrupted Life for Microelectronic Systems  
*Oliver M. Barham*

**DETC2022-91306** ..... **V008T08A014**  
Alpha-Photovoltaics for Milliwatt Applications  
*Muhammad Khan, Marc Litz, Johnny Russo, and Randy Tompkins*

### **Micro/Nano Robotics and Functional Materials**

**DETC2022-89906** ..... **V008T08A015**  
Carbon/PEEK/Zirconia Hybrid Composite for High-Performance Applications  
*Claudia Pagano, Vito Basile, Rossella Surace, Roberto Terzi, Monica Schioppa, Barbara Palazzo, and Irene Fassi*